Experimental Studies of Vulnerabilities in Devices and On-Chip Protection



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Introduction



- Study effects on the fundamental units of IC circuits, ie individual devices (MOSFETs) and gates (CMOS Inverters).
- Identify most prominent vulnerabilities of the units to RF direct injection and irradiation, and examine how they critically affect circuit operation.
- Establish the failure mechanisms for each regime and develop hardened IC device/circuit designs.
- Evaluate response of device with RF pulse parameters and use MOSFET devices as on-chip sensing and protecting elements.
- Develop on-chip sensing, registration, and protection circuitry.
- Develop protective nano-composite polymer based "spin-on" coatings.

Approach



- Assume RF signals couple to devices through I/O/antenna ports, and neglect bouncing signals within the packaged chip.
- Chips containing several individual enhancement mode N-channel MOSFETs of varying dimensions were fabricated and packaged in transistor headers for testing under RF.
- PC Boards were designed and fabricated and the packaged chips were placed on the boards with matching elements for RF injection.
- The RF vulnerabilities are examined both by simulation and experimental injection of RF at the MOSFETGate, Drain, Source, and Body.
- The On-Chip "Sense-and-Protect" circuit is being developed. Several prototypes have been fabricated and tested.

Outline

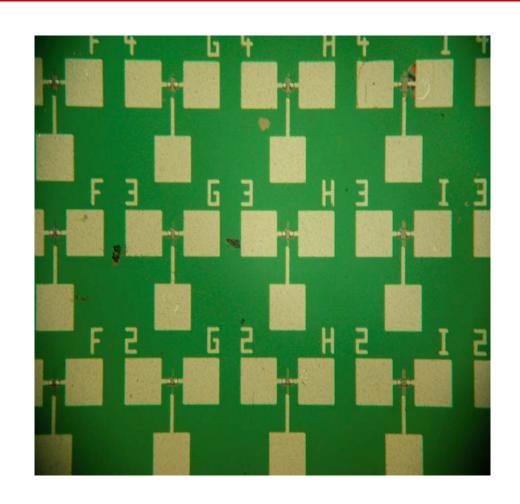


- MOSFET IC Chip and Packaging
- MOSFET simulation of RF injection using P-SPICE and MEDICI
- Two cases: a. dc operational point upset and b. upset with legitimate small ac signal at input
- Experimental RF injection in packaged devices
- On-chip "Sense-and-Protect" development and test
- Summary
- Continuing Work
- Future-Goals

IC Chip with Individual MOSFETs



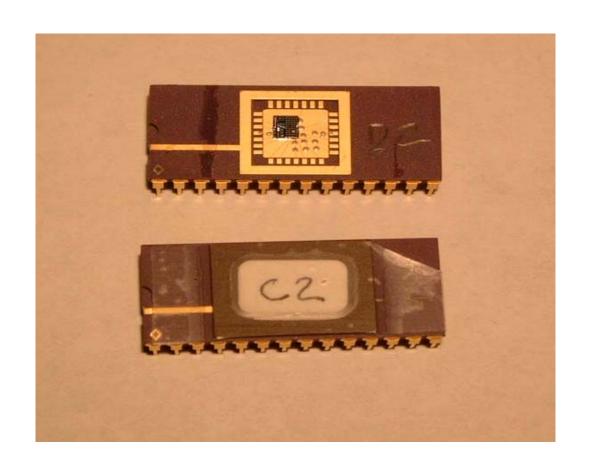
- IC Chip with Enhancement-Mode n-channel MOSFETs
- Gate Length varies between 2um-20um.
- Parameters affected:
- Electronic: I-V, Q point, gm, gain, delay times, ft, fm, s, impedences
- Physical: Gate oxide, junction boundaries, metallizations.



Packaged Chip for RF Test



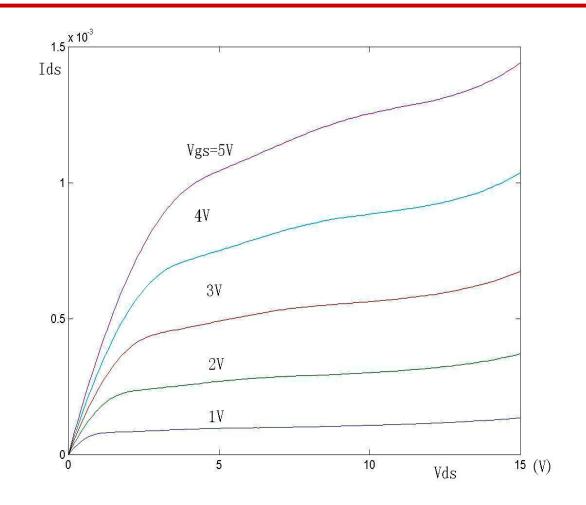
- Bonded and packaged IC Chip
- Several devices are wire-bonded for RF testing
- Operating conditions: VDD=5 V
- Packaged chip is placed on PC board for RF test



Family of I-V Output Characteristics

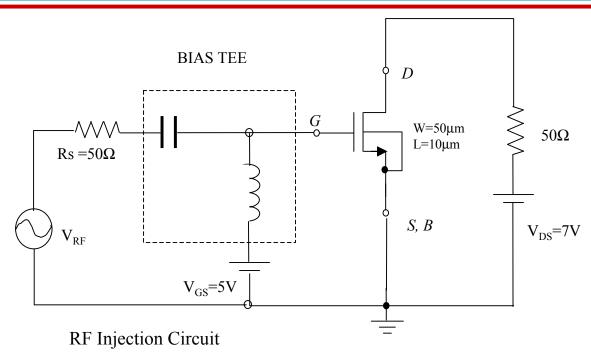


- Typical dc I-V characteristic of a MOSFET
- Operating point at Vds=7V and Vgs=2.5V



Simulation using P-SPICE





DC Biased Circuit

Circuit for P-SPICE simulation using a T junction for RF injection. RF amplitude: 1 and 4 V.

RF frequencies: 20MHz, 100MHz, 500MHz, 2GHz, & 20GHz.

500MHz RF Injection to Gate



$$\mathbf{I}_{\mathbf{DRF}} = \mathbf{I}_{\mathbf{D}} + \Delta \mathbf{I}_{\mathbf{DRF}}$$

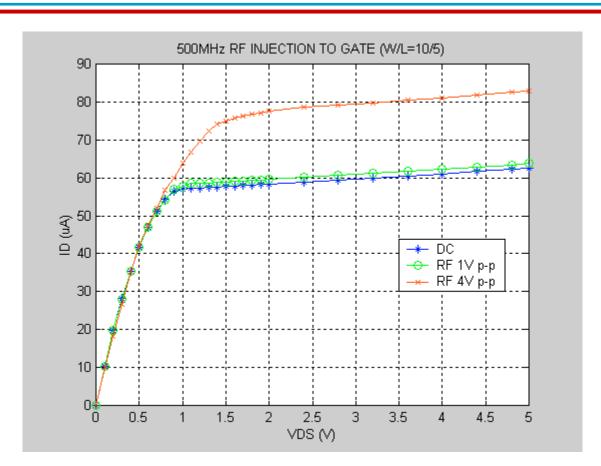
Where:

 $I_D : DC bias$

current

 ΔI_{DRF} : increase of drain current due

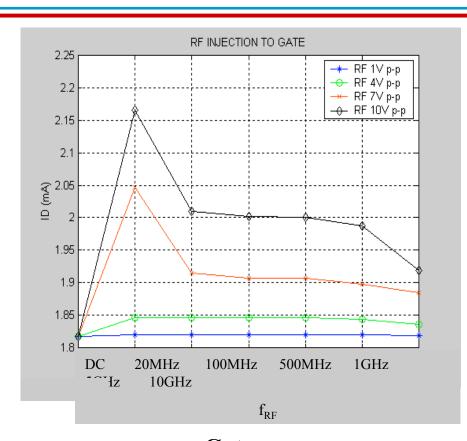
to RF injection

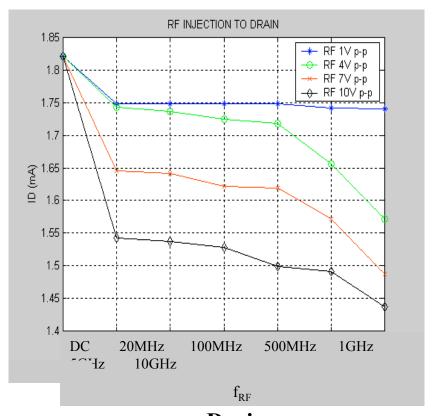


Family of I-V characteristics at DC and 500 MHz for sinusoid RF. The DC gate bias per characteristic is at V_{GS} =2 V and W/L=10/5

RF Injection to Gate, Drain





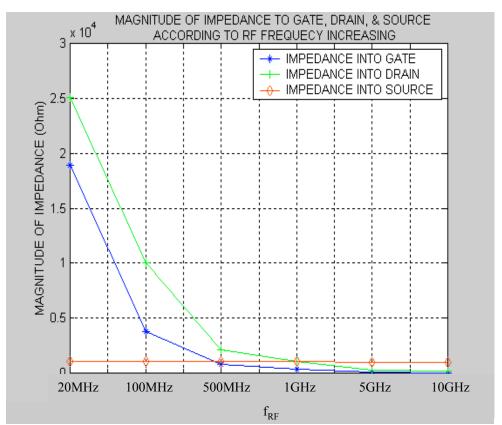


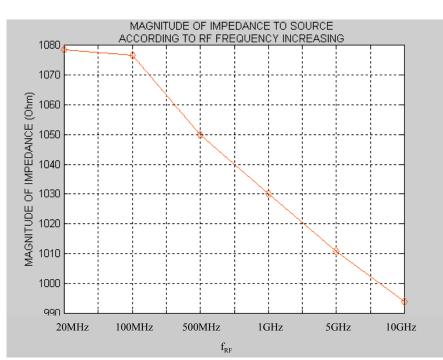
Gate

Drain

 ΔI_{DRF} vs RF Frequency and amplitude. RF amplitude from 1V to 10V and frequency from DC to 10GHz. $V_{GS} = 5V$, $V_{DS} = 7V$.

Magnitude of effective impedance with injected RF frequency



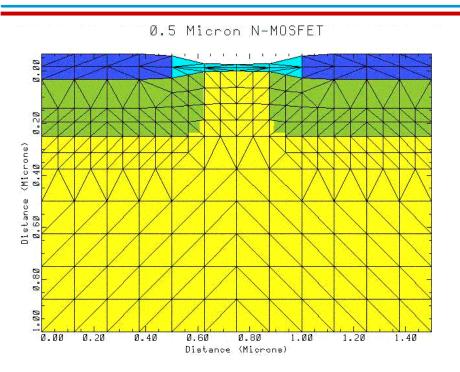


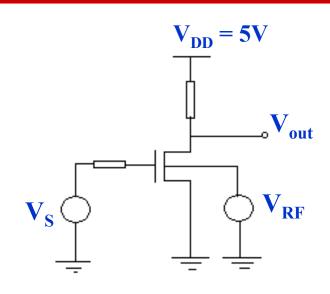
56

The magnitude of impedance looking into Gate, Drain, and Source is decreasing with RF frequency.

Simulation with both input signal and RF injection using MEDICI-Avanti







• $V_{AC} = 0.2\sin(10^82\pi t)$, f: 100MHz

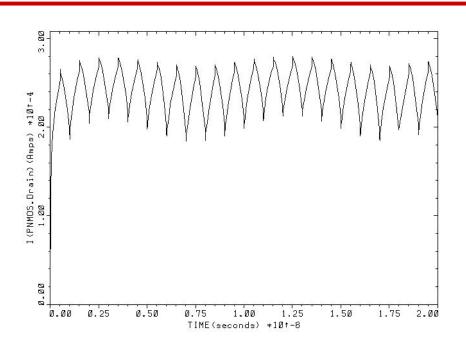
 $\bullet Vgs = 2.5 V$

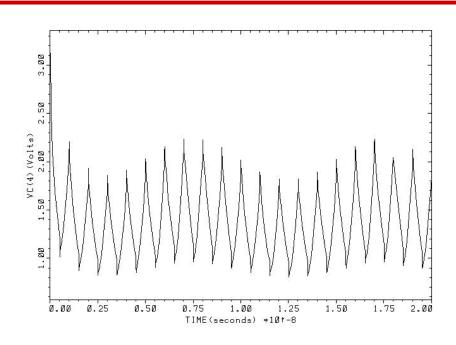
• $V_{RF} = 1V, 3V, 5V.$

RF pulses: 500MHz, 1GHz

Small signal at gate and RF Injected at Body (Substrate)







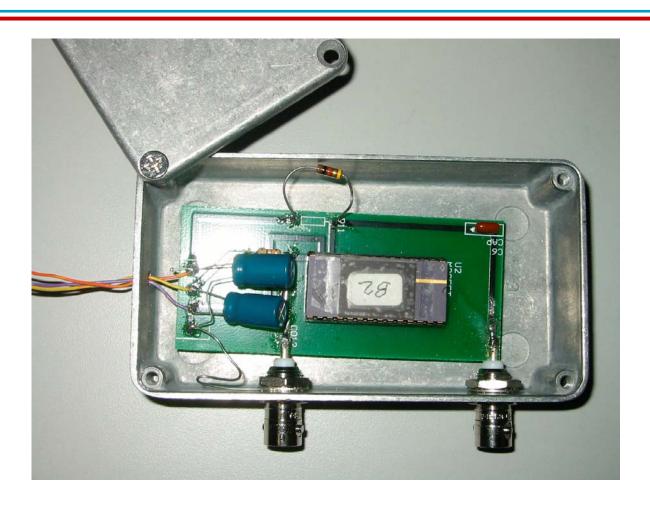
Drain Current

Drain Voltage

Input signal at gate is 100 MHz sinusoid. Output waveforms modulated by RF pulsed injection at the Body. Similar modulation is observed for RF injection at the Source. RF: 1 GHz, 3V

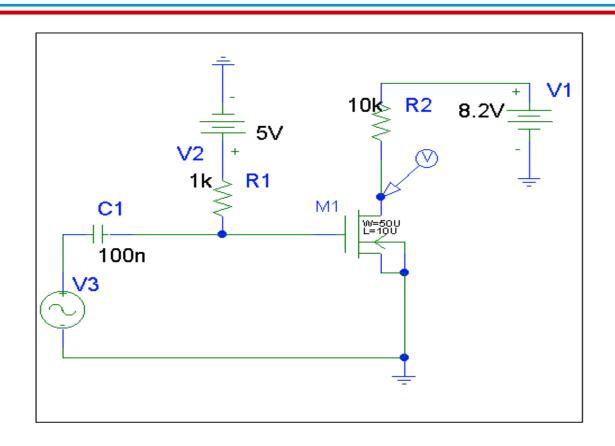
Device Under Test (DUT) on PC Board 18 THERSIT





Circuit Diagram of the MOSFET RF Test Device

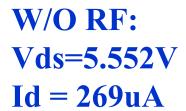


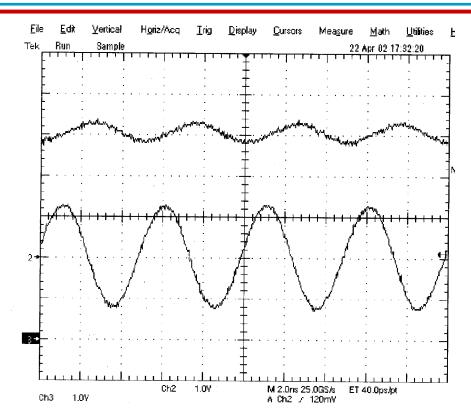


Circuit diagram of device under test (DUT). Device is in IC package and package is soldered onto PC board and in aluminum box. Matching components are shown.

RF injection at Gate







With RF injected (200MHz, 2.4 V)

Vds=5.051V Id = 305uA

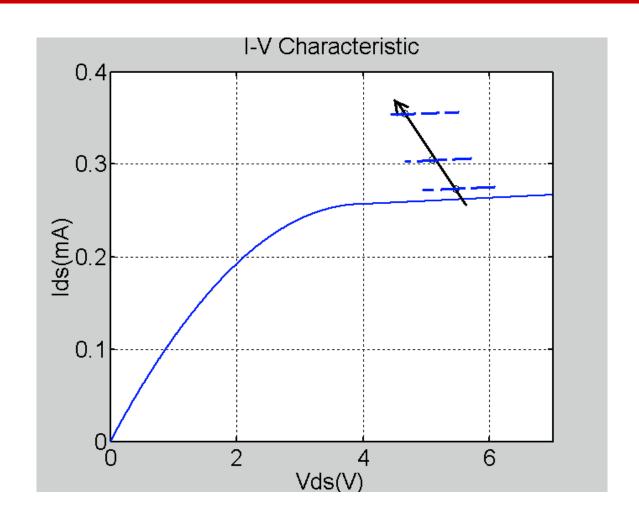
☐ Id=36uA(13%)

Upper line: experimental output voltage (Vds) vs time with RF showing the dc average output voltage at the drain is reduced by 13%

Id increase due to RF injection at Gate

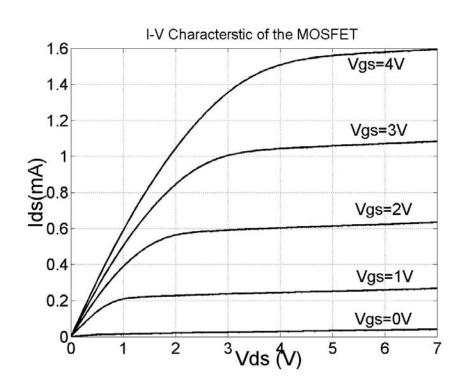


Equivalent Id increase with amplitude of RF injection signal at gate



Id increase due to non-linearity?





$$I_{d} = \frac{\mu_{n} c_{ox} W}{2L} (V_{gs} - V_{t})^{2} (1 + \lambda V_{ds})$$

$$\frac{\mu_n c_{ox}}{2} = 1.3e - 5$$
 Vt= -0.96
 $\lambda = 1.3e - 3$ W/L=5

Device test for non-linearity



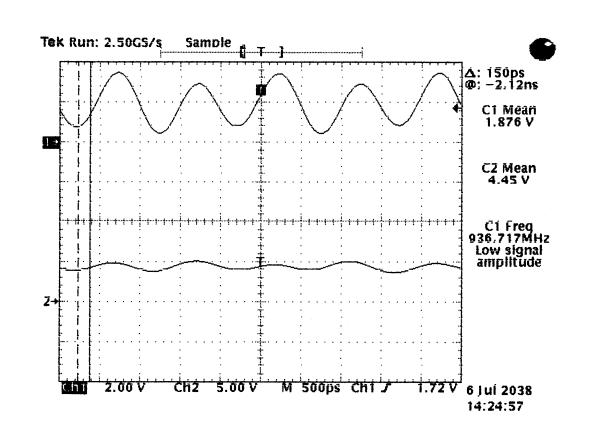
W/O RF:Vd=6.07V

With RF at Gate:

1GHz, **3V**

Vd=4.45V

Id = 0.565mA



Upper curve is Vgs, lower curve is Vds (with RF). RF lowers the drain voltage and increased the drain current.

Simulation result for non-linearity



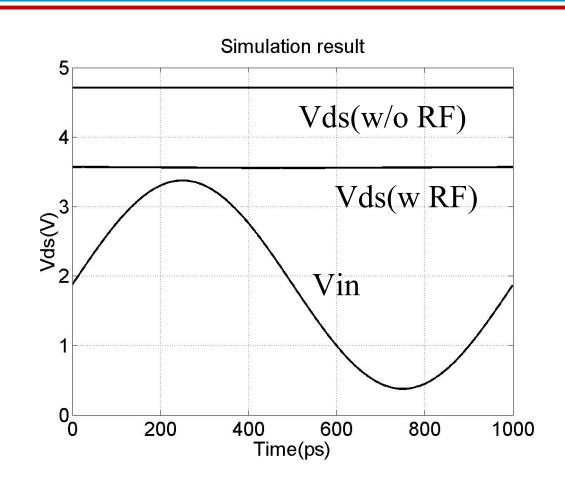
Measurement:

Vds: 6.07V → 4.45V

Simulation:

Vds: 4.71V → 3.57V

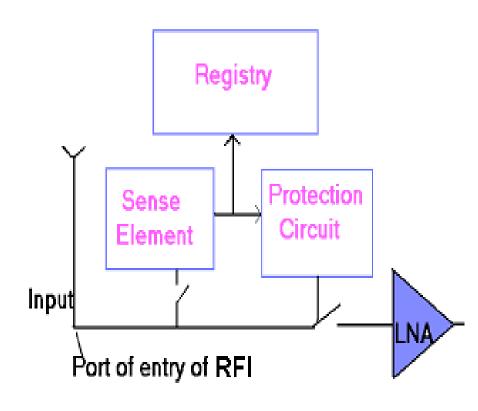
Measurement and simulation show similar trend



"Sense and Protect" Circuit Concept



- Sense element based on "floating gate" MOSFETs of different size and geometries.
- Protection based on comparators and fast switches.
- Efficient disconnect capability with minimal coupling to the rest of circuit in the off-state
- Designed for wide frequency and amplitude range of events
- It registers RF events
- Patent Pending



Schematic of Protection System

"Sense-and-protect" chip test



Legitimate input signal:

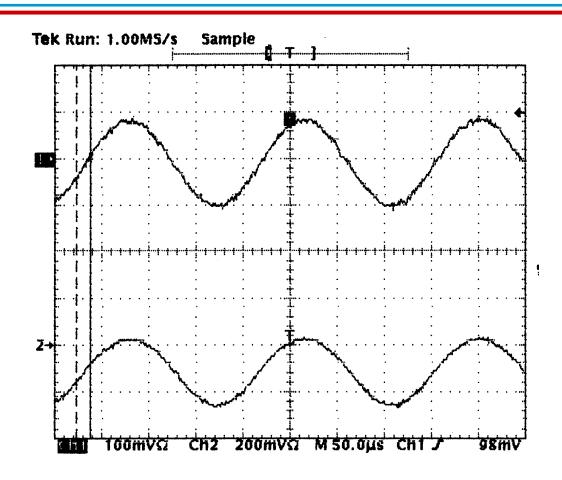
Amplitude: 200mV

Output signal:

amplitude: 280mV

(Gain:1.4)

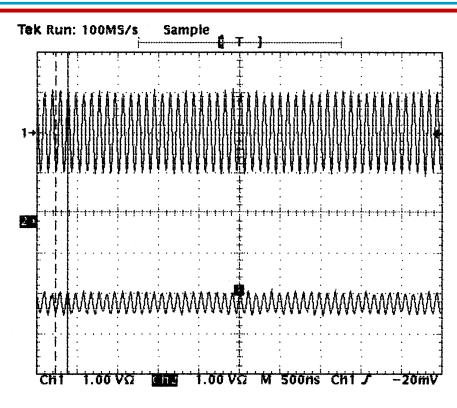
•Phase shift:0



Upper curve is input, lower curve is output from S-P chip

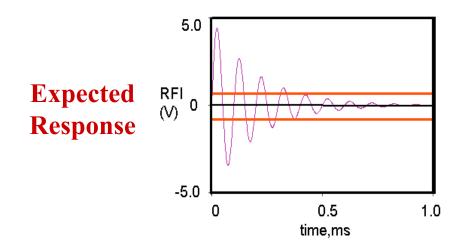
"Sense-and-Protect" RF Blocking





RF Input signal: f~10 MHz, 2V

Output: 0.5V



Upper curve is input, lower curve is output from S-P chip. Inset on right is the expected response for blocking RF.

Summary



- Simulated and experimental RF injection on MOSFETs at the gate, showed an increase in the drain current possibly due to the non-linearity in I-V characteristics.
- This drain current change appears to decrease with increasing RF frequency
- RF injection at the drain appears to reduce drain current probably due to non-ideal output conductance effects
- RF injection at body and source modulates and distorts legitimate input signals
- The non-linearities in I-V output characteristics (quadratic, output conductance, break-down) are some main factors
- On-chip "Sense-and-Protect" circuit was tested. All sections were tested and found to operate as designed, except for the switching elements that did not fully switched off thus a 20% signal pass-through.

Summary-Continuing Work



- Improvements in the design and fabrication of the switches and an additional circuit to avoid disruption of the operation while blocking the RF signal, are being implemented.
- The "sense-and-protect" circuit will also be scaled down to submicron gate lengths for faster response and higher RF frequencies and implemented with "wide" gates designed to effectively collect RF radiation as antennas and register each RF event to help with the understanding of radiation distribution within the packaging (Antonsen, Ott, Ramahi).
- It will then be incorporated in the design of the main communication chip (Goldsman, Jacob, Melngailis, Baker) to protect and register RF events at the I/O points of the chip.
- Direct RF radiation experiments are underway to establish vulnerabilities in the devices and map their dc and ac characteristics with RF amplitude and frequency.

Summary-Future Goals



- We have begun to experiment with protective coatings on polymers intended to completely shield the chips from radiation by developing a "spin-on" polymer and nanocomposite metal system.
- Our overall approach is to develop the understanding of how the unit cells of IC circuits in analog and digital mode react to RF radiation, map the vulnerabilities, develop protection on the chip level, and (re)design devices to harden against RF.
- Develop active shielding within chip environment to disrupt radiation patterns.